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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****
 JAPAN 2002-254858 08/30/2002

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 1
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Verified and Acknowledged
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 22850
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TITLE
 Manufacturing method of a semiconductor substrate provided with a through hole electrode

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)

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